W 7-13-00 Nmd+ #17/C



35.C11946

PATENT APPLICATION

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: C. Dexter

AKIRA FUNAKOSHI, ET AL.

Art Unit 3724

Application No.: 08/801,464

Filed: February 18, 1997

For: SUBSTRATE CUTTING METHOD

AND SUBSTRATE CUTTING

**APPARATUS** 

July 10, 2000

(Monday)

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JUL 12 200
TC 3700 NAIL ROOM

The Commissioner for Patents Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment and Response to Ex Parte Quayle in the above-identified application.

X No additional fee is required.

The fee has been calculated as shown below:

	CLAIMS		CLAIMS AS AM	ENDED		
	REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	34	MINUS	34	= 0	x \$9 \$18	\$ 0.00
INDEP. CLAIMS	6	MINUS	6	= 0	x \$39 \$78	\$ 0.00
Fee for Multiple Dependent claims \$130°/\$260						\$
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0.00

	°Verified Statement claiming sonot filed previously.	mall entity status is enclosed, if						
	A check in the amount of \$	is enclosed.						
	Charge \$ to Deposit Acc this sheet is enclosed.	ount No. 06-1205. A duplicate of						
х	Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.							
	A check in the amount of \$extension is enclosed.	to cover the fee for a month						
	A check in the amount of \$ to cover the Information Disclosure Statement fee is enclosed.							
x	Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.							
		Respectfully submitted,						
Attorney for Applicants Registration No. 33,326  FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200								

Page 2 of 2

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The Com	missioner for Patents			EIVE 12 21		
Washingt	ton, D.C. 20231					
				ROOM		
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# AMENDMENT AND RESPONSE TO EX PARTE QUAYLE

Sir:

In response to the Office Action dated May 8, 2000, please amend the above-identified application as follows:

# IN THE SPECIFICATION:

Please amend the specification as follows: